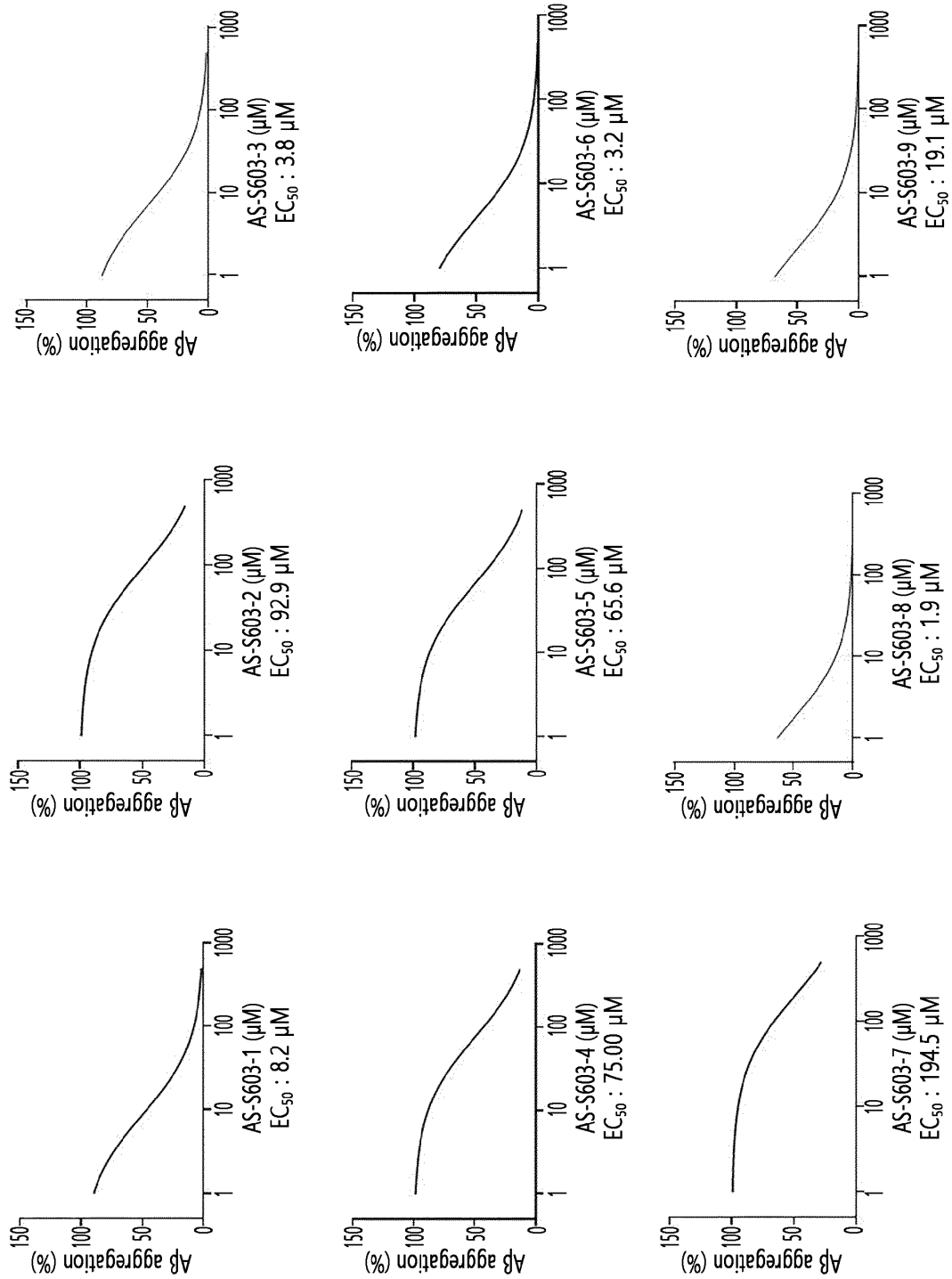


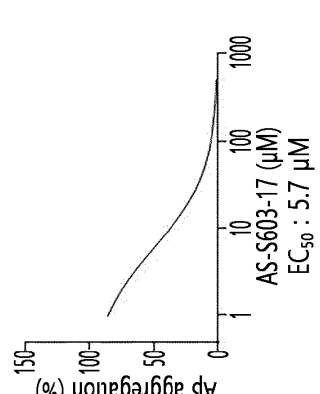
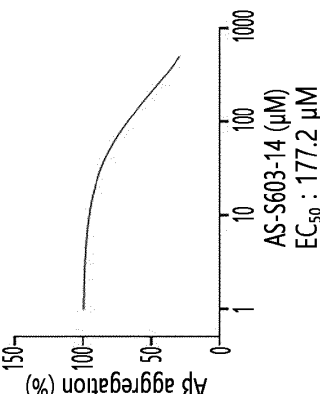
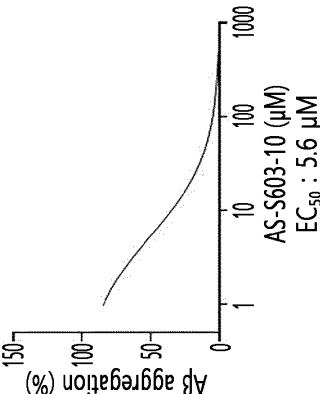
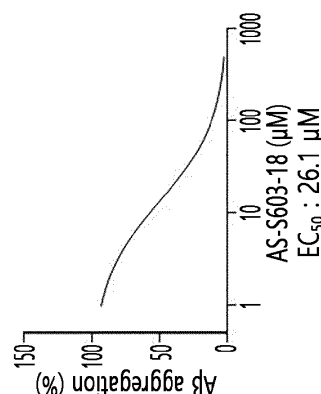
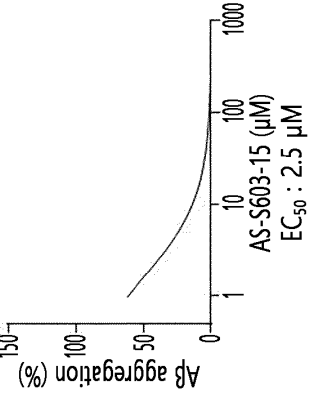
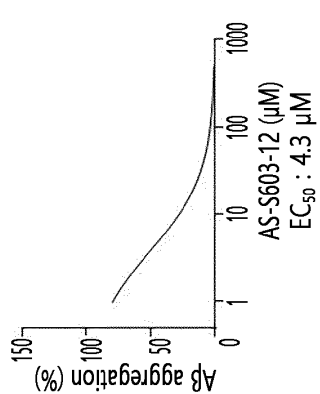
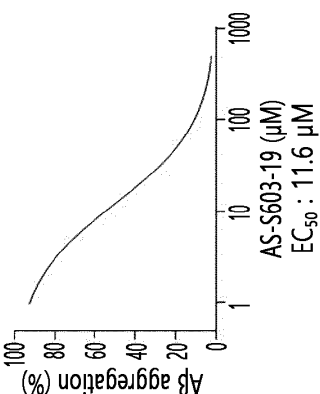
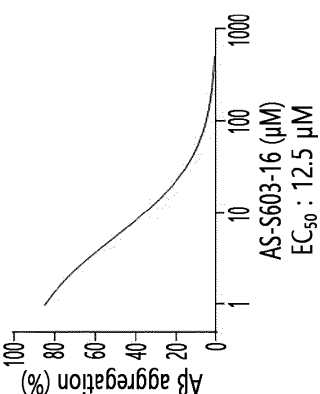
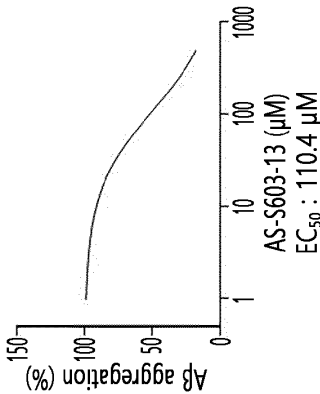
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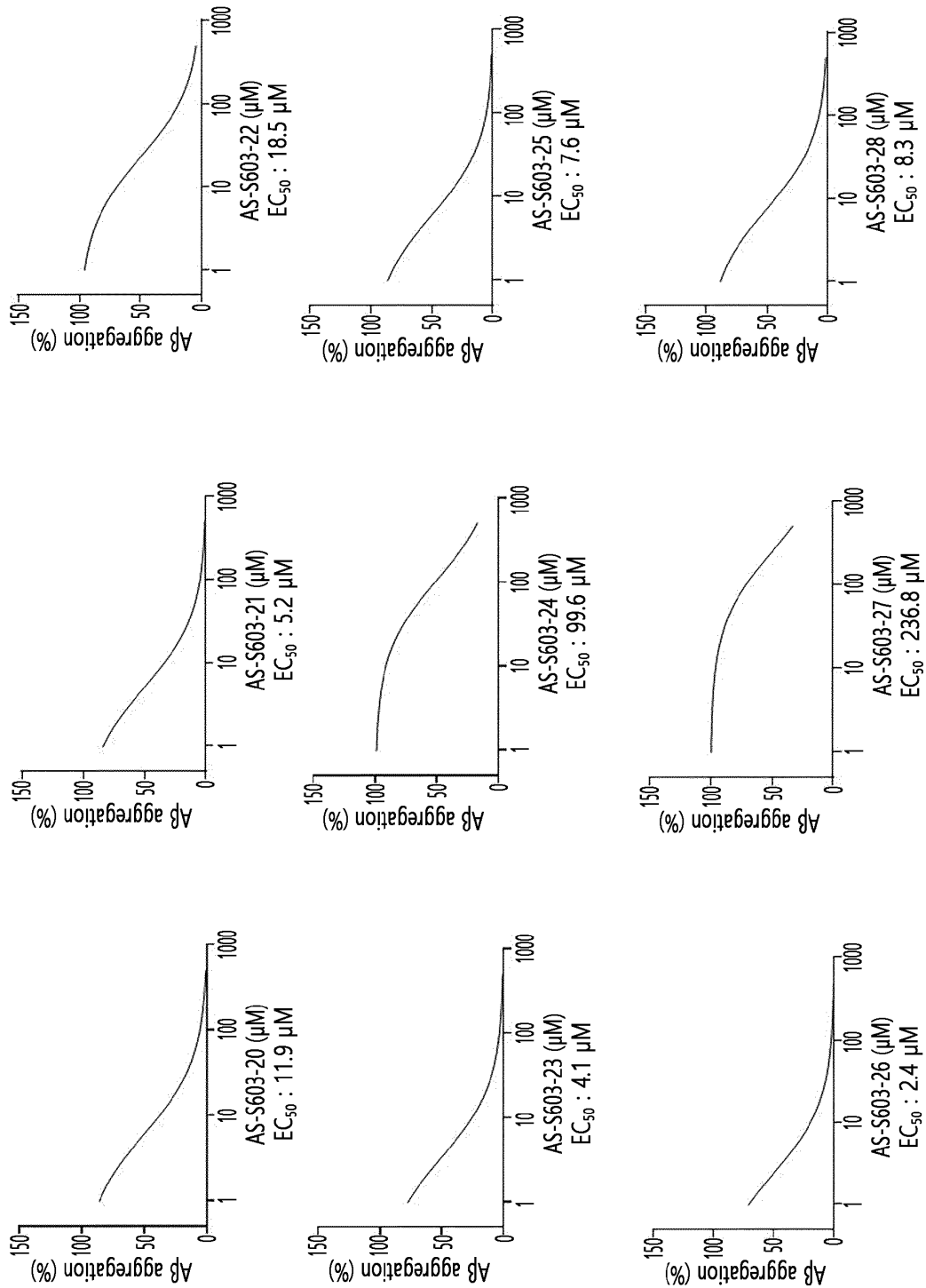
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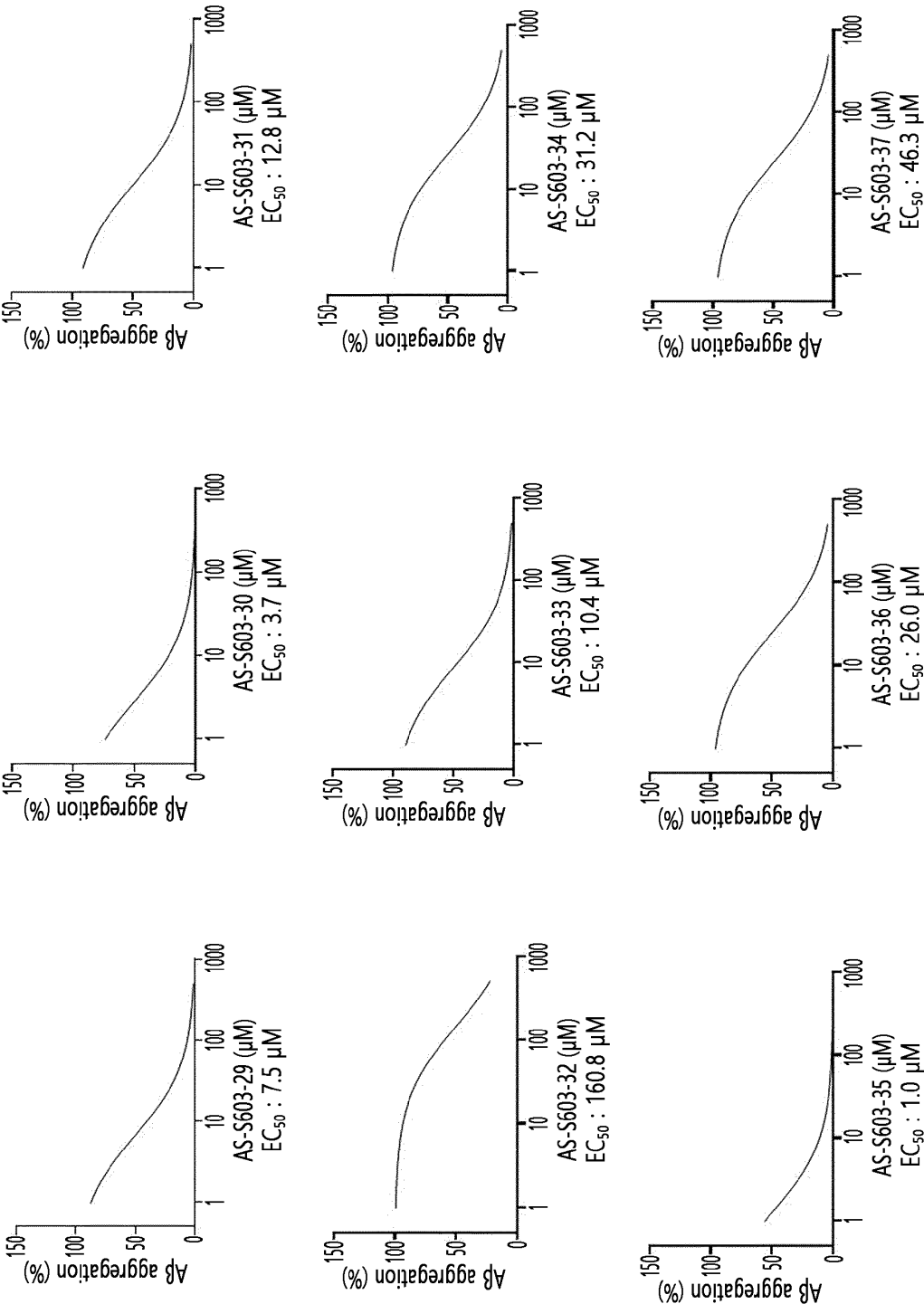
[도2]



[圖3]



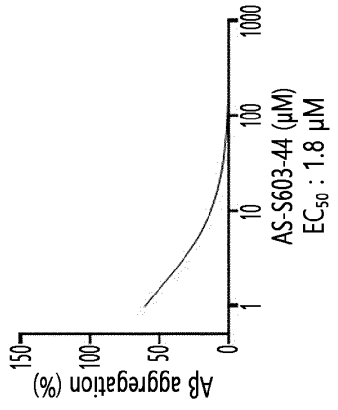
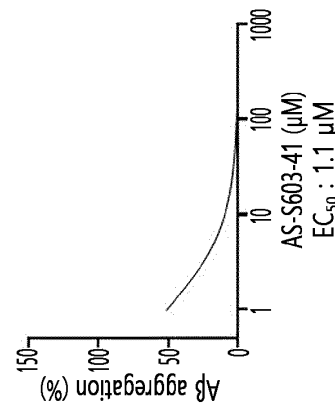
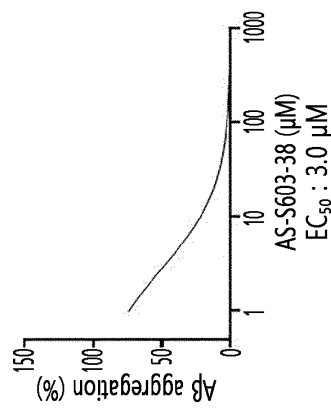
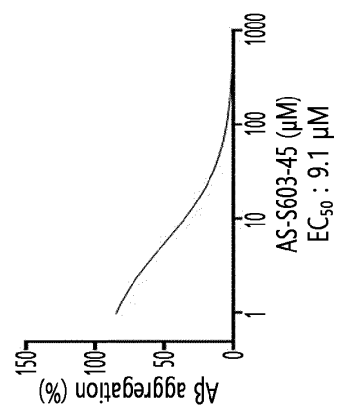
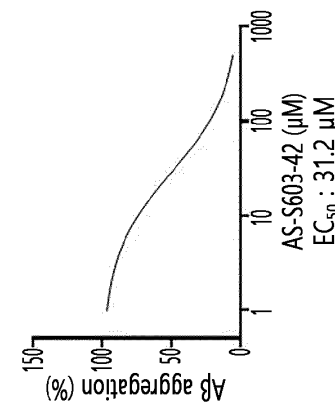
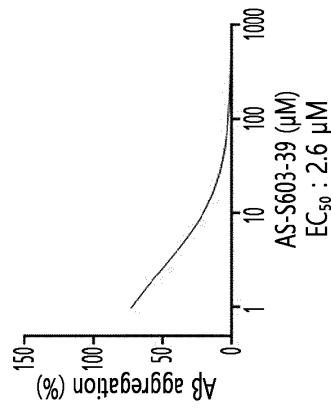
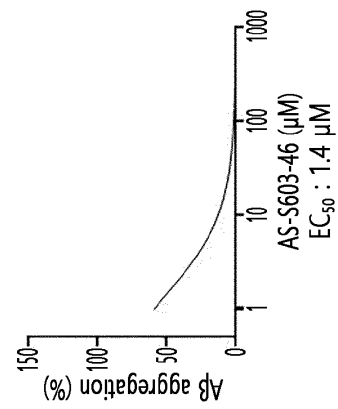
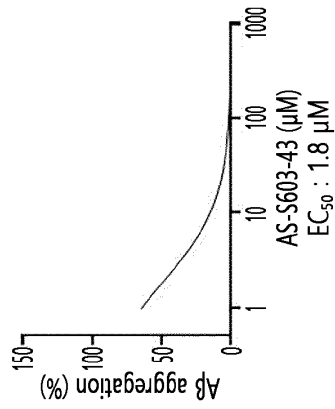
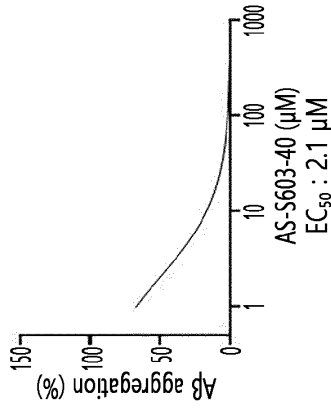
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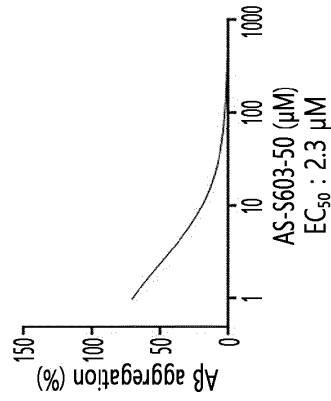
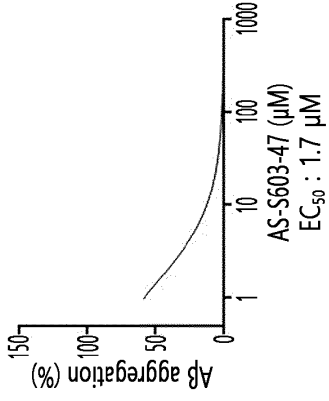
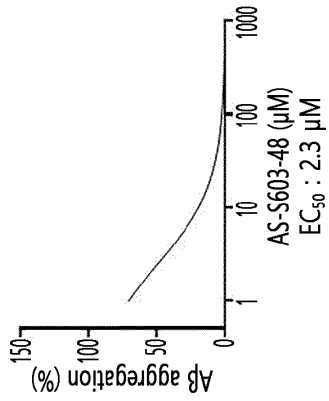
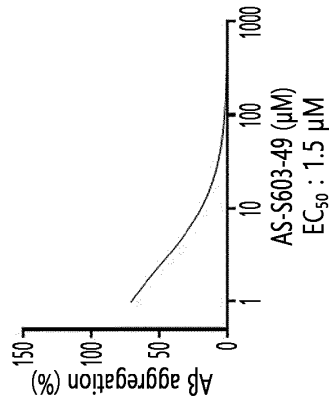
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[5]



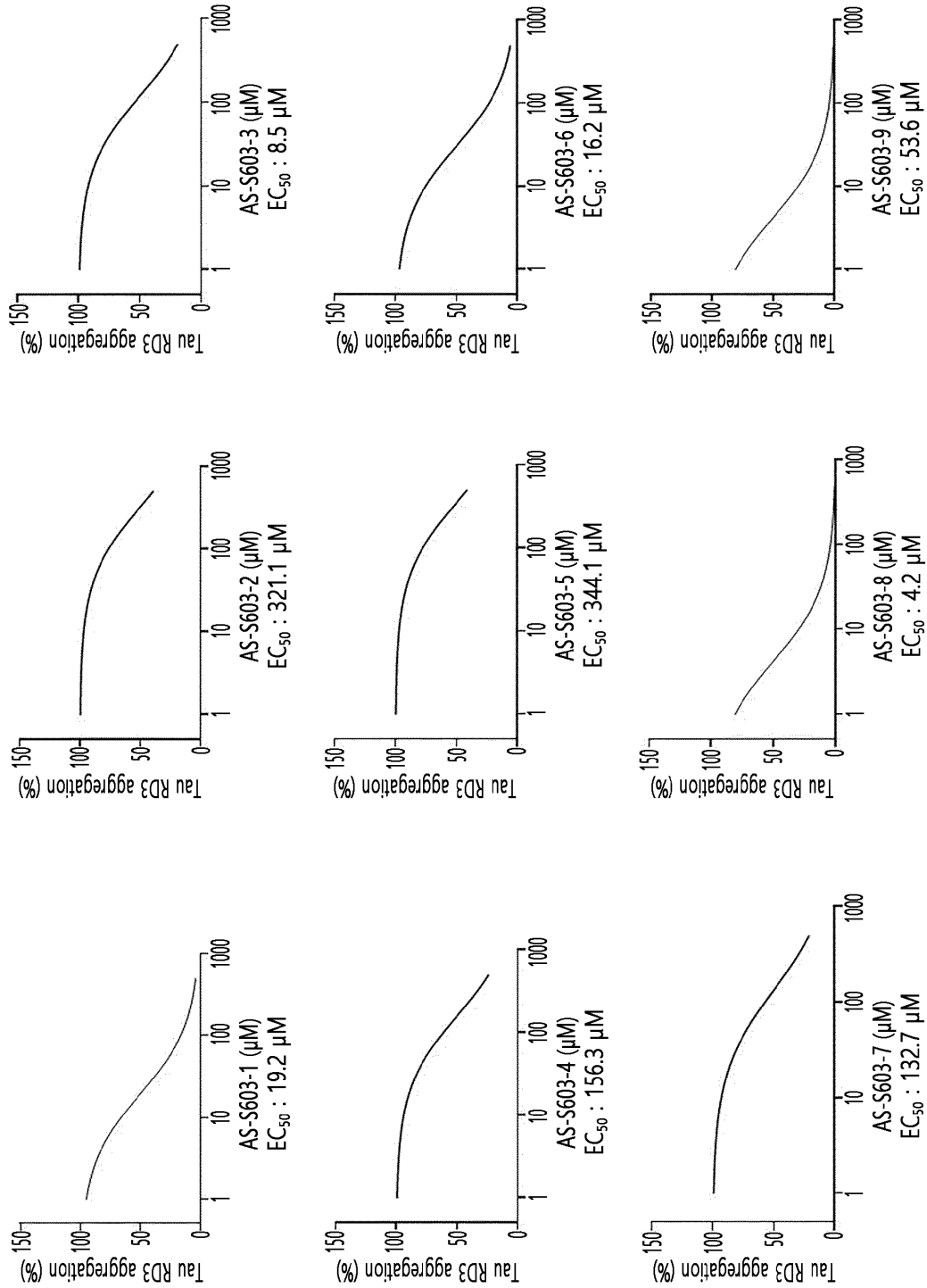
[도6]



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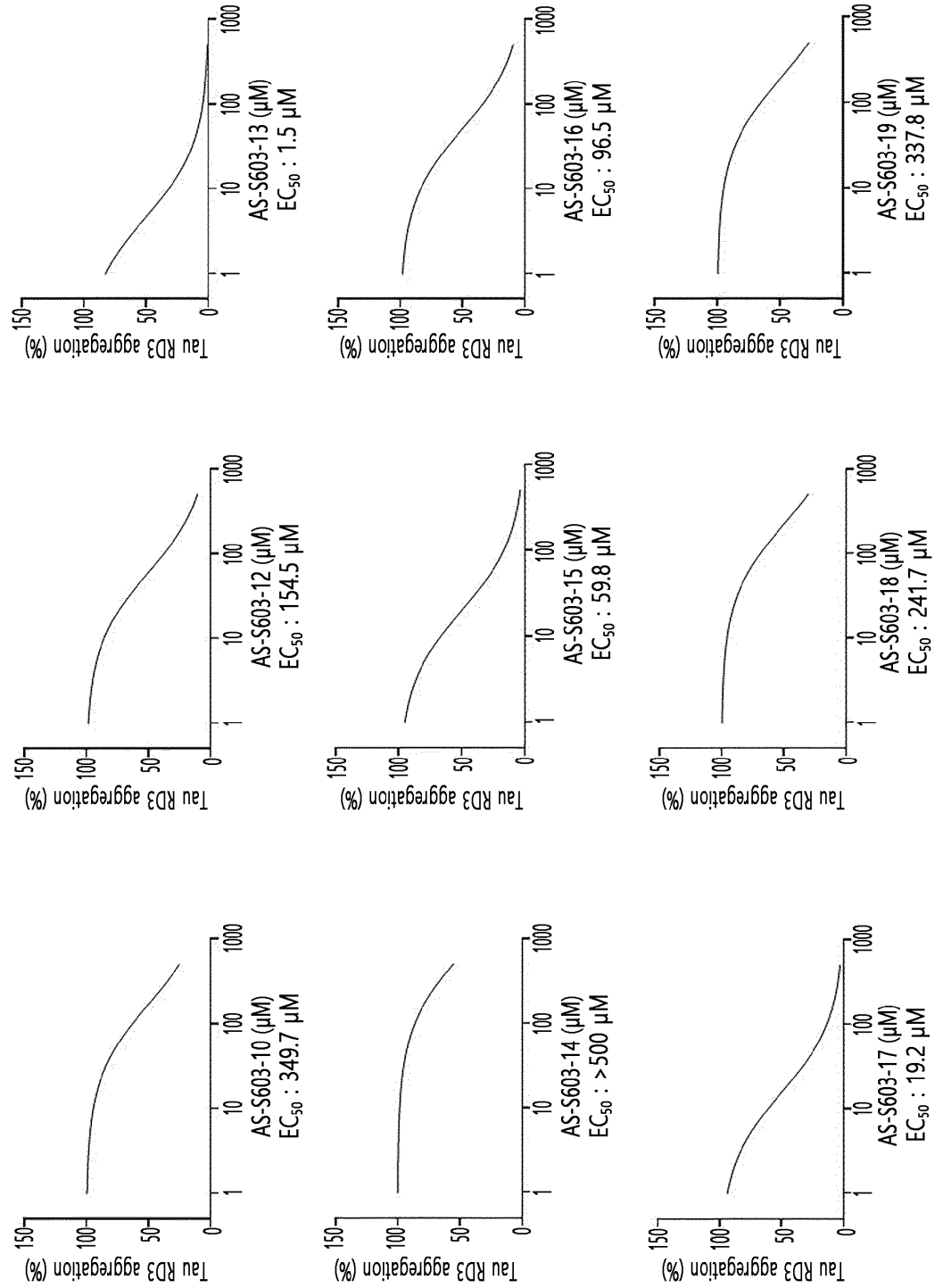
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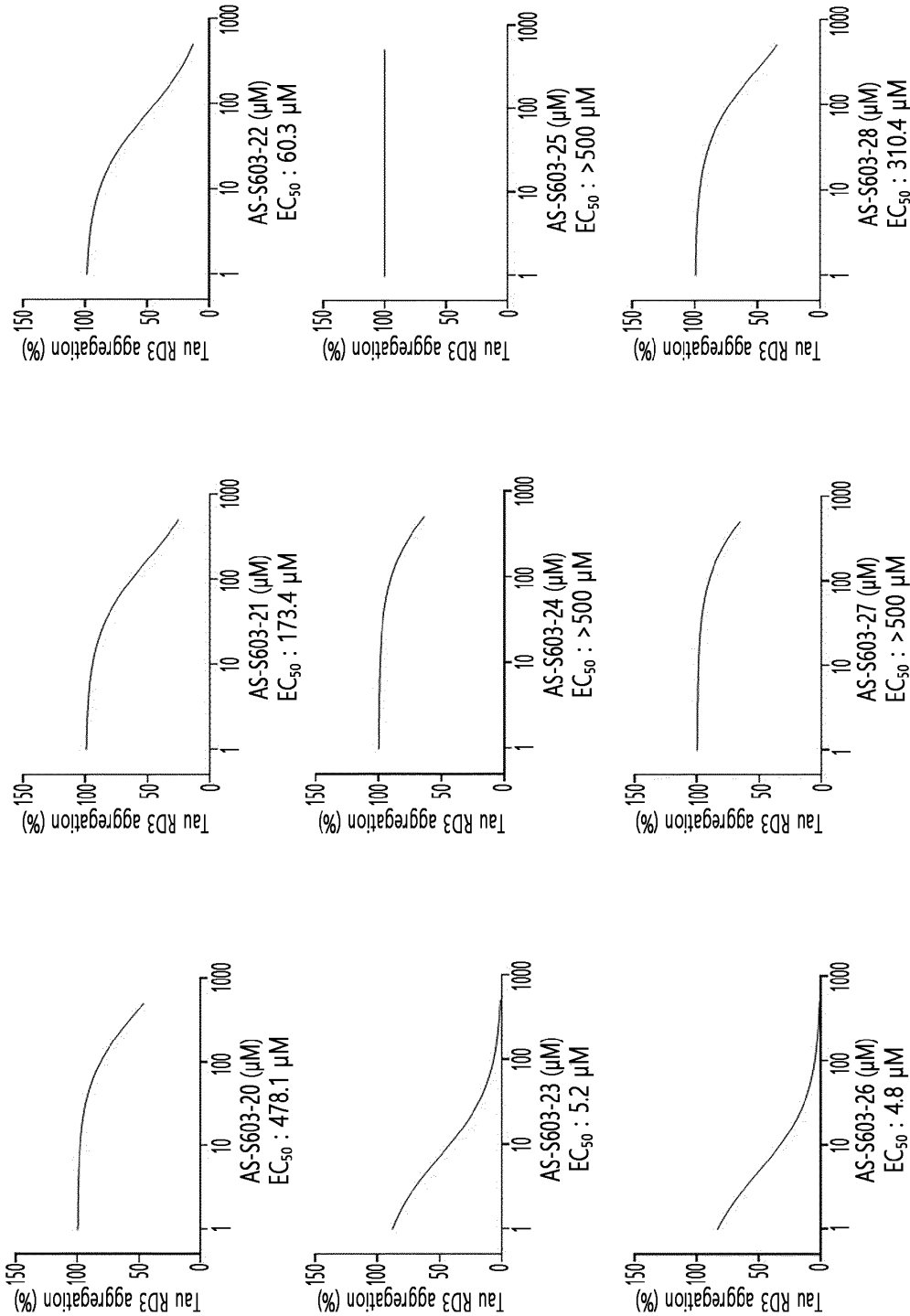
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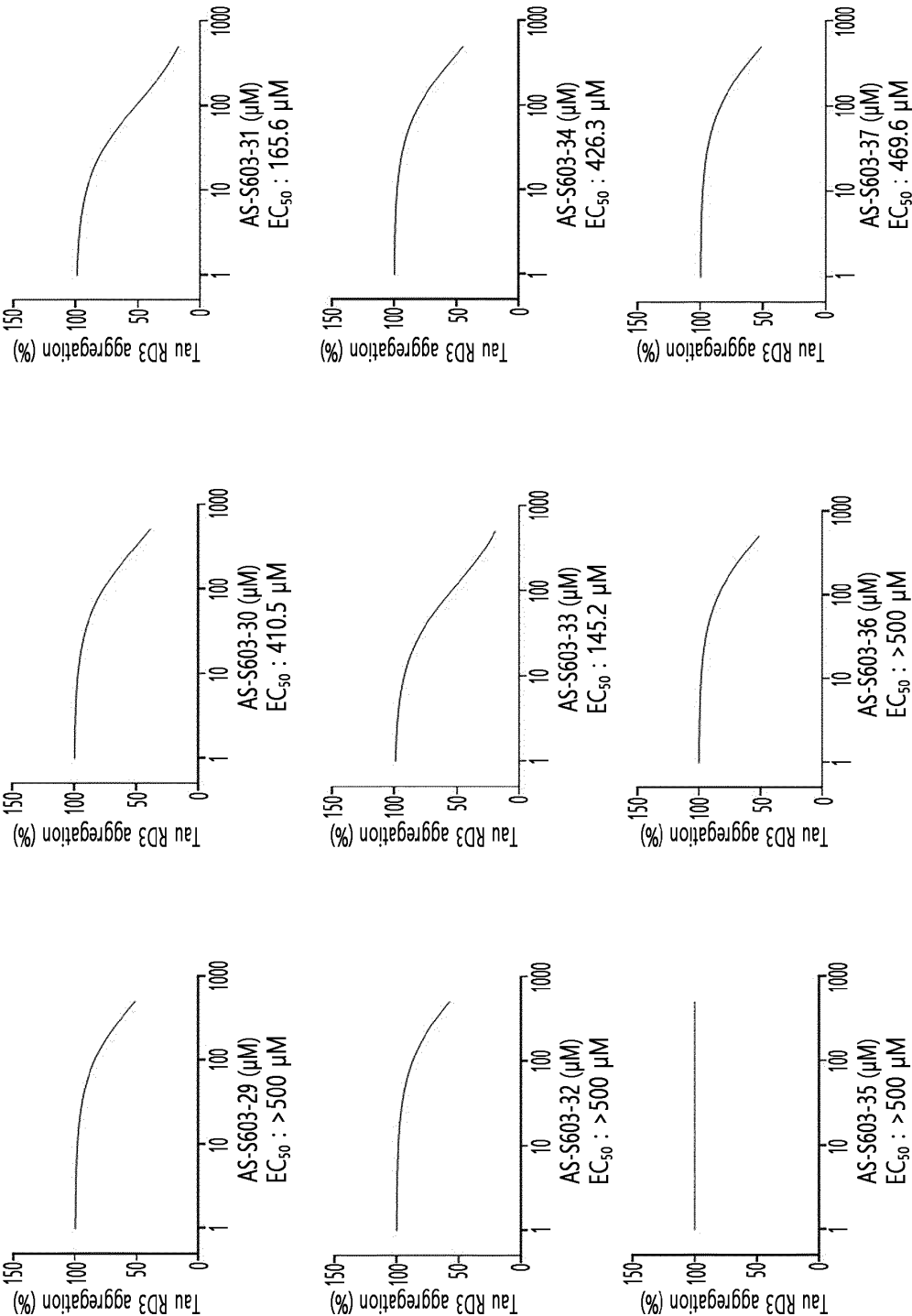
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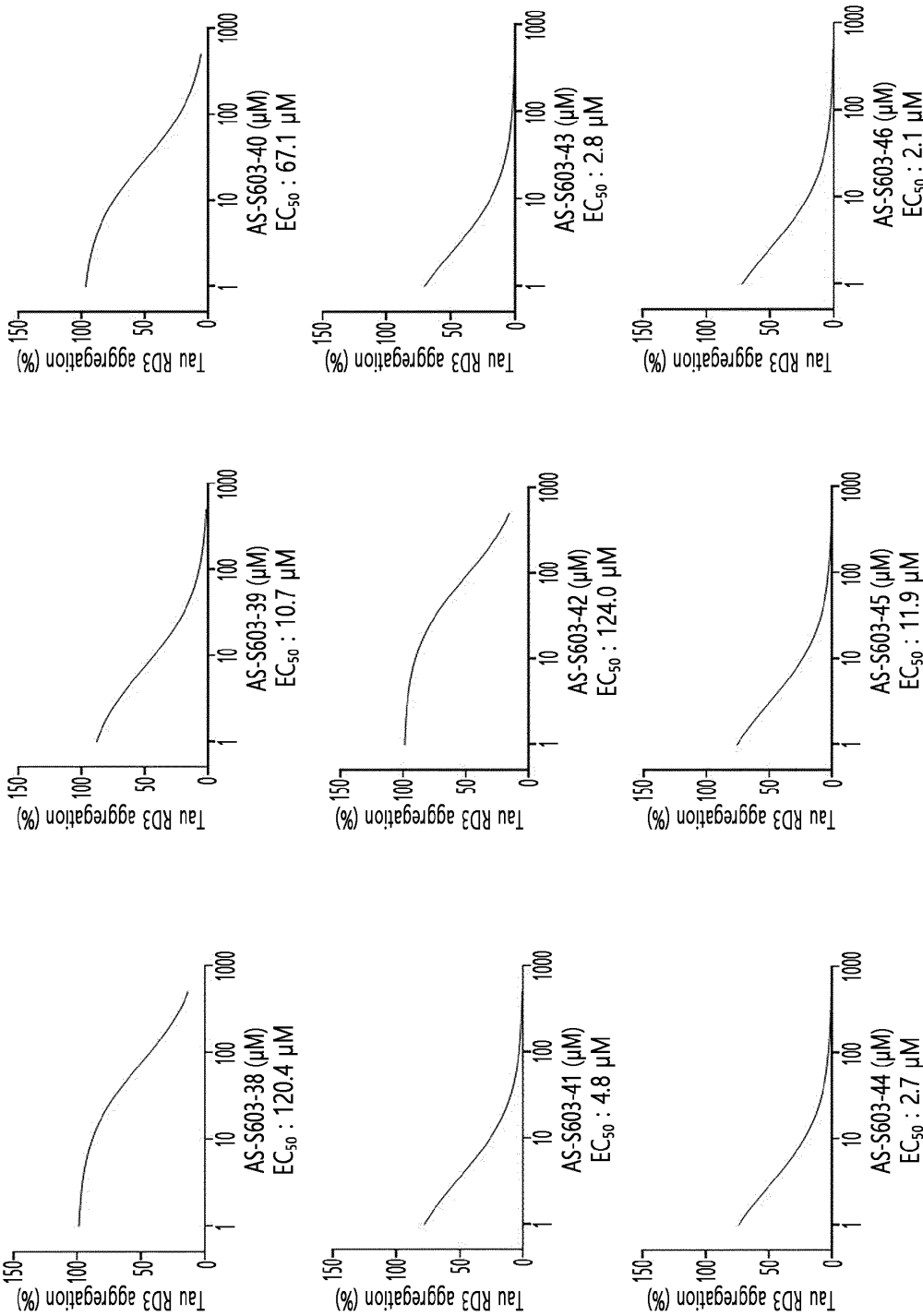
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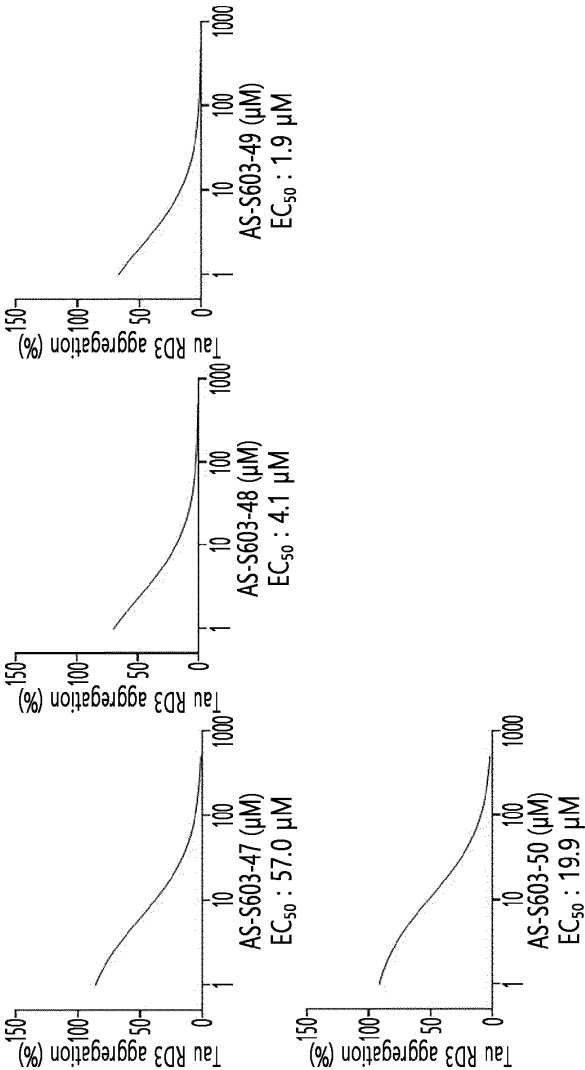
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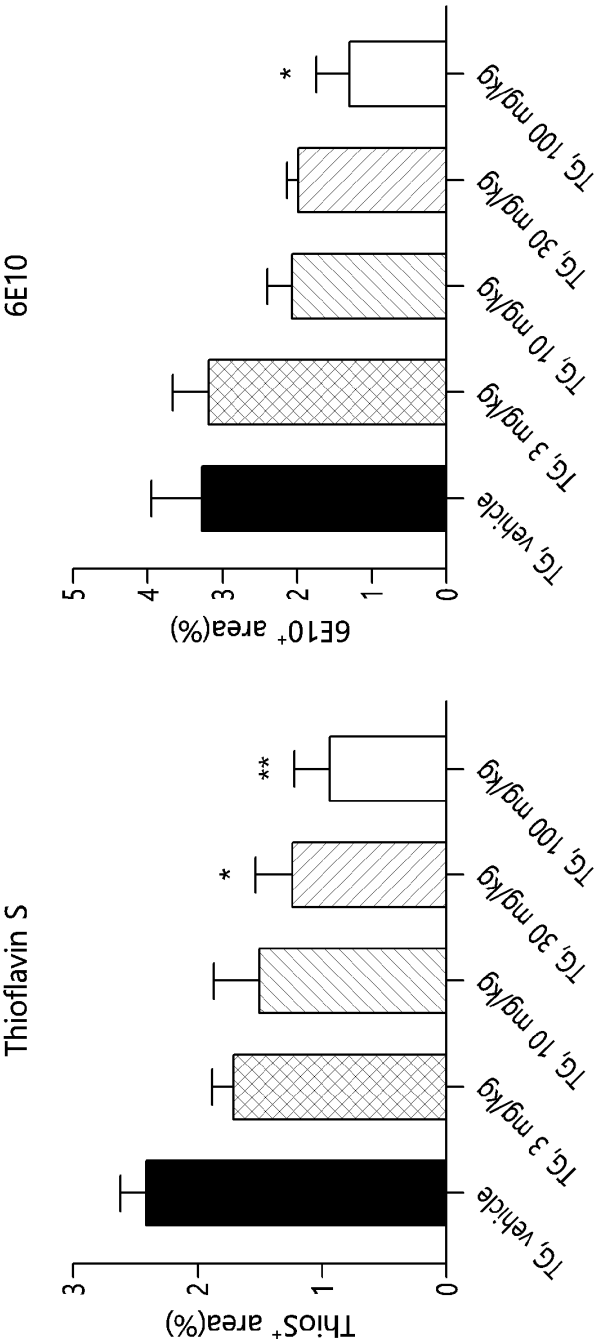
[도11]



[도 12]



[도13]



[圖14]

